Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

Location(s) where activities are performed under accreditation

Head Office

Science Park Eindhoven 5108, Gebouw 2 5692 EC Son en Breugel The Netherlands

Location	Abbreviation/ location code
Science Park Eindhoven 5108, Gebouw 2 5692 EC Son en Breugel The Netherlands	LAB
On-site at the customer	os

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
LF 0 0	DC/LF Quantities				
LF 1 0	DC Voltage			measuring and generating	
	10 V		5·10 ⁻⁷ · <i>U</i>	zenerreferences	LAB
	1 V and 1.018 V		2.3·10 ⁻⁶ · <i>U</i>	zenerreferences	LAB
	0 μV to 10 μV		0.3 μV		LAB
	10 μV to 200 mV		$3.10^{-6} \cdot U + 0.2 \mu\text{V}$		LAB
	200 mV to 1 V		3·10 ⁻⁶ · <i>U</i>		LAB
	1 V to 2 V		2·10 ⁻⁶ · <i>U</i>		LAB
	2 V to 10 V		1·10 ⁻⁶ · <i>U</i>		LAB

This annex has been approved by the Board of the Dutch Accreditation Council, on its behalf,

J.A.W.M. de Haas Director of Operations

Dutch Accreditation Council RvA Page 1 of 11

¹ Calibration and Measurement Capability (CMC): Demonstrated measurement uncertainty, with coverage probability of 95%, in a given measurement point or measurement range. Measurement uncertainty, *U*, is calculated according to EA-4/02 "*Evaluation* of the Uncertainty of Measurement in Calibration".

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
LF 1 0	10 V to 1000 V		2·10 ⁻⁶ · <i>U</i>		LAB
	1000 V to 1100 V		4·10 ⁻⁶ · <i>U</i>		LAB
	9 V to 16 V		3.4 mV		os
	295 V to 400 V		70 mV		os
LF 2 0	DC Current			measuring and generating	
	1 μA to 10 μA		3·10 ⁻⁵ · I		LAB
	10 μA to 20 A		2·10 ⁻⁵ · I		LAB
	0,5 A to 5 A		2.5 mA		os
LF 3 0	AC Voltage			measuring and generating	LAB
	100 mV to 220 mV	10 Hz to 20 Hz	3·10 ⁻⁴ · <i>U</i>		
		20 Hz to 40 Hz	5·10 ⁻⁵ · <i>U</i>		
		40 Hz to 20 kHz	5·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	5·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	6·10 ⁻⁵ · <i>U</i>		
		100 kHz to 200 kHz	2·10 ⁻⁴ · <i>U</i>		
		200 kHz to 500 kHz	4·10 ⁻⁴ · <i>U</i>		
		500 kHz to 1 MHz	7·10 ⁻⁴ · <i>U</i>		
	220 mV to 2.2 V	10 Hz to 20 Hz	5·10 ⁻⁵ · <i>U</i>		
		20 Hz to 40 Hz	5·10 ⁻⁵ · <i>U</i>		
		40 Hz to 20 kHz	5·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	4·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	5·10 ⁻⁵ · <i>U</i>		
		100 kHz to 200 kHz	2·10 ⁻⁴ · <i>U</i>		
		200 kHz to 500 kHz	4·10 ⁻⁴ · <i>U</i>		
		500 kHz to 1 MHz	7·10 ⁻⁴ · <i>U</i>		
	2.2 V to 22 V	10 Hz to 20 Hz	5·10 ⁻⁵ · <i>U</i>		

Dutch Accreditation Council RvA Page 2 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
LF 3 0	2.2 V to 22 V	20 Hz to 40 Hz	4·10 ⁻⁵ · <i>U</i>		LAB
		40 Hz to 20 kHz	4·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	4·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	5·10 ⁻⁵ · <i>U</i>		
		100 kHz to 200 kHz	2·10 ⁻⁴ · <i>U</i>		
		200 kHz to 500 kHz	4·10 ⁻⁴ · <i>U</i>		
		500 kHz to 1 MHz	8·10 ⁻⁴ · <i>U</i>		
	22 V to 220 V	10 Hz to 20 Hz	6·10 ⁻⁵ · <i>U</i>		
		20 Hz to 40 Hz	5·10 ⁻⁵ · <i>U</i>		
		40 Hz to 20 kHz	5·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	5·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	2·10 ⁻⁴ · U		
	220 V to 1000 V	10 Hz to 20 Hz	5·10 ⁻⁵ · <i>U</i>		
		20 Hz to 40 Hz	5·10 ⁻⁵ · <i>U</i>		
		40 Hz to 20 kHz	5·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	7·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	4·10 ⁻⁴ · <i>U</i>		
LF 3 3	Pulse Amplitude				LAB
	1 mV to 25 mV	10 Hz to 10 kHz	5·10 ⁻³ · <i>U</i>	measuring	
	25 mV to 110 mV	10 Hz to 10 kHz	2.6·10 ⁻⁴ · <i>U</i>		
	110 mV to 2.2 V	10 Hz to 10 kHz	2.6·10 ⁻⁴ · <i>U</i>		
	2.2 V to 11 V	10 Hz to 10 kHz	2.6·10 ⁻⁴ · <i>U</i>		
	11 V to 130 V	10 Hz to 10 kHz	2.6·10 ⁻⁴ · <i>U</i>		
	6 mV to 25 mV	10 Hz to 10 kHz	1·10 ⁻² · <i>U</i>	generating	
	25 mV to 110 mV	10 Hz to 10 kHz	5-10 ⁻³ - <i>U</i>		
	110 mV to 2.2 V	10 Hz to 10 kHz	5·10 ⁻³ · <i>U</i>		

Page 3 of 11

Dutch Accreditation Council RvA

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
LF 3 3	2.2 V to 11 V	10 Hz to 10 kHz	5·10 ⁻³ · <i>U</i>		LAB
	11 V to 130 V	10 Hz to 10 kHz	5·10 ⁻³ · <i>U</i>		
LF 3 4	AC/DC Transfer			measuring and generating	LAB
	0.5 V to 50 V	40 Hz to 1 kHz	5.6·10 ⁻⁵ · <i>U</i>		
		1 kHz to 20 kHz	5.1·10 ⁻⁵ · <i>U</i>		
		20 kHz to 100 kHz	6.1·10 ⁻⁵ · <i>U</i>		
		100 kHz to 500 kHz	2.5·10 ⁻⁴ · <i>U</i>		
	0.5 V to 10 V	500 kHz to 1 MHz	4.2·10 ⁻⁴ · <i>U</i>		
	50 V to 100 V	40 Hz to 1 kHz	4.5·10 ⁻⁵ · <i>U</i>		
		1 kHz to 20 kHz	4.5·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	5.1·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	5.6·10 ⁻⁵ · <i>U</i>		
	100 V to 500 V	40 Hz to 1 kHz	6.2·10 ⁻⁵ · <i>U</i>		
		1 kHz to 20 kHz	5.8·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	9.2·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	2.4·10 ⁻⁴ · <i>U</i>		
	500 V to 1000 V	40 Hz to 20 kHz	6.4·10 ⁻⁵ · <i>U</i>		
		20 kHz to 50 kHz	9.6·10 ⁻⁵ · <i>U</i>		
		50 kHz to 100 kHz	2.4·10 ⁻⁴ · <i>U</i>		
LF 4 0	AC Current			measuring and generating	LAB
	100 μA to 1 mA	10 Hz to 1 kHz	3.2·10 ⁻⁴ ·/		
		1 kHz to 5 kHz	2.6·10 ⁻⁴ · /		
		5 kHz to 10 kHz	6.5·10 ⁻⁴ · /		
		10 kHz to 20 kHz	1.2·10 ⁻³ · /	measuring only	
	1 mA to 10 mA	10 Hz to 1 kHz	2.3·10 ⁻⁴ · /		

Dutch Accreditation Council RvA Page 4 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
LF 4 0	1 mA to 10 mA	1 kHz to 5 kHz	1.7·10 ⁻⁴ · <i>I</i>		LAB
		5 kHz to 10 kHz	4.3·10 ⁻⁴ · <i>I</i>		
		10 kHz to 20 kHz	6.7·10 ⁻⁴ ·/	measuring only	
	10 mA to 1 A	10 Hz to 1 kHz	2.4·10 ⁻⁴ · <i>I</i>		
		1 kHz to 5 kHz	2.1·10 ⁻⁴ ·/		
		5 kHz to 10 kHz	4.9·10 ⁻⁴ · <i>I</i>		
		10 kHz to 20 kHz	8.2·10 ⁻⁴ · <i>I</i>	measuring only	
	1 A to 5 A	10 Hz to 1 kHz	2.4-10-4-/		
		1 kHz to 5 kHz	2.8·10 ⁻⁴ · <i>I</i>		
		5 kHz to 10 kHz	7.4·10 ⁻⁴ · <i>I</i>		
		10 kHz to 20 kHz	1.4·10 ⁻³ ·/	measuring only	
	5 A to 20 A	10 Hz to 1 kHz	3.3-10-4-/		
		1 kHz to 5 kHz	3.8-10-4-/		
		5 kHz to 10 kHz	7.8·10 ⁻⁴ · <i>I</i>		
		10 kHz to 20 kHz	1.4·10 ⁻³ ·/	measuring only	
LF 6 2	DC Resistance			measuring and generating	LAB
	1 mΩ		3·10 ⁻⁵ · R		
	10 mΩ		2·10 ⁻⁵ · R		
	100 mΩ		1·10 ⁻⁵ · R		
	1 Ω		3·10 ⁻⁶ · R		
	10 Ω		3·10 ⁻⁶ ·R		
	100 Ω		3·10 ⁻⁶ · R		
	1 kΩ		3·10 ⁻⁶ ·R		
	10 kΩ		2·10 ⁻⁶ ·R		
	100 kΩ		3·10 ⁻⁶ ·R		
	1 ΜΩ		3·10 ⁻⁶ · R		
	10 ΜΩ		5·10 ⁻⁶ ·R		

Dutch Accreditation Council RvA Page 5 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
LF 6 2	100 MΩ		2·10 ⁻⁵ ·R		LAB
	1 GΩ		6·10 ⁻⁴ · R		
	1 m Ω to 10 m Ω		9·10 ⁻⁵ ·R		
	10 m Ω to 100 m Ω		3·10 ⁻⁵ ·R		
	100 m Ω to 1 Ω		2·10 ⁻⁵ ·R		
	1 Ω to 10 M Ω		5·10 ⁻⁶ ·R		
	10 M Ω to 100 M Ω		2·10 ⁻⁵ ·R		
	100 M Ω to 1 G Ω		6·10 ⁻⁴ · R		
LF 6 5	LF Capacitance			measuring and generating	LAB
	10 pF	1 kHz to 10 kHz	2·10 ⁻⁵ ·C		
	100 pF	1 kHz to 10 kHz	2·10 ⁻⁵ ·C		
	1 pF to 50 pF	1 kHz to 10 kHz	2·10 ⁻⁴ ·C		
	50 pF to 100 pF	1 kHz to 10 kHz	4·10 ⁻⁵ · C		
	100 pF to 1 nF	1 kHz to 5 kHz	2·10 ⁻⁵ ·C		
	1 nF to 1 μF	1 kHz	2·10 ⁻⁴ ·C		
	1 μF to 10 μF	100 Hz	3·10 ⁻⁴ · C		
	200 μF to 500 μF	DCV	1.2·10 ⁻³ · C		
	500 μF to 110 mF	DCV	1·10 ⁻³ · C		
RF 0 0	HIGH FREQUENCY QUANTITIES				
RF 1 0	CW Flatness				LAB
	5 mV _{pp} to 200 mV _{pp}	50 kHz to 1100 MHz	3.5·10 ⁻² related to 50 kHz/50 Ω	measuring	

Dutch Accreditation Council RvA Page 6 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
RF 1 0	200 mVpp to 6 Vpp	50 kHz to 1100 MHz	3.5·10 ⁻² related to 50 kHz/50 Ω	measuring	LAB
	5 mV _{pp} to 20 mV _{pp}	50 kHz to 1100 MHz	11·10 ⁻² related to 50 kHz/50 Ω	generating VSWR scope ≤ 1.3	
	20 mV _{pp} to 6 V _{pp}	50 kHz to 1100 MHz	10·10 ⁻² related to 50 kHz/50 Ω	generating VSWR scope ≤ 1.3	
TF 0 0	TIME & FREQUENCY				
TF 2 1	Frequency			measuring and generating	LAB
	10 MHz		6·10 ⁻¹¹ · f		
	10 mHz to 1 MHz		1·10 ⁻¹⁰ · f + T _e	1)	
	1 MHz to 300 MHz		1·10 ⁻¹⁰ · f		
	300 MHz to 1.1 GHz		6·10 ⁻⁹ ·f	2)	
TF 2 2	Time Interval				LAB
	1 μs to 10 s		5·10 ⁻¹⁰ · <i>t</i> + T.E.	5) measuring only	
	10 s to 10 ⁵ s		5·10 ⁻¹⁰ · <i>t</i> + 10 ns	measuring only	
TF 2 3	Phase Angle				LAB
	0 ° to 180 °	10 Hz to 50 Hz	0.05 °	at equal input voltages 100 mV < Ui < 300 V generate up to 120 V	
		50 Hz to 1 kHz	0.08 °		
		1 kHz to 5 kHz	0.18 °		
		5 kHz to 10 kHz	0.35 °		

Dutch Accreditation Council RvA Page 7 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

Measured quantity, Range	Frequency	CMC ¹	Remarks	Location
0 ° to 180 °	10 kHz to 30 kHz	0.75 °		LAB
	50 Hz	0.10 °	unequal input voltages 100 mV < Ui < 300 V ratio 1:100	
	50 Hz to 1 kHz	0.25 °		
	1 kHz to 5 kHz	0.40 °		
	5 kHz to 10 kHz	1.0 °		
	10 kHz to 30 kHz	1.8 °		
Rise time				LAB
70 ps to 1000 ps	pulse repeat ≤1 MHz	20 ps	180 mV _{pp} to 300 mV _{pp} in 50 Ω measuring only	
	0 ° to 180 ° Rise time	0 ° to 180 ° 10 kHz to 30 kHz 50 Hz 50 Hz to 1 kHz 1 kHz to 5 kHz 5 kHz to 10 kHz 10 kHz to 30 kHz Rise time 70 ps to 1000 ps pulse repeat ≤1	0 ° to 180 ° 10 kHz to 30 kHz 0.75 ° 50 Hz 0.10 ° 50 Hz to 1 kHz 0.25 ° 1 kHz to 5 kHz 0.40 ° 5 kHz to 10 kHz 1.0 ° 10 kHz to 30 kHz 1.8 ° Rise time 70 ps to 1000 ps pulse repeat ≤1 20 ps	0 ° to 180 ° 10 kHz to 30 kHz 0.75 ° 50 Hz 0.10 ° unequal input voltages 100 mV < Ui < 300 V ratio 1:100 50 Hz to 1 kHz 0.25 ° 1 kHz to 5 kHz 0.40 ° 5 kHz to 10 kHz 1.0 ° 10 kHz to 30 kHz 1.8 ° Rise time 70 ps to 1000 ps pulse repeat ≤1 MHz 20 ps 180 mV _{pp} to 300 mV _{pp} in 50 Ω

HCS code	Measured quantity, Instrument, Measure	Range	CMC ²	Remarks	Location
PV 0 0	Pressure				
PV 1 1	Absolute pressure	10 kPa to 60 kPa	10 Pa	nitrogen, measuring	LAB
		60 kPa to 700 kPa	$3.1 \cdot 10^{-5} \cdot p + 10 \text{ Pa}$	and generating	
		700 kPa to 10 MPa	4.2·10 ⁻⁵ · <i>p</i> + 95 Pa		
PV 1 2	Gauge pressure	0 kPa to 15 kPa	3.5·10 ⁻⁵ · p_e + 0.48 Pa	nitrogen, measuring and generating	LAB
		15 kPa to 700 kPa	$3.5 \cdot 10^{-5} \cdot p_{e} + 6.1$		
		700 kPa to 10 MPa	$4.2 \cdot 10^{-5} \cdot p_{\rm e} + 95 \text{Pa}$		

² Calibration and Measurement Capability (CMC): Demonstrated measurement uncertainty, with coverage probability of 95%, in a given measurement point or measurement range. Measurement uncertainty, *U*, is calculated according to EA-4/02 "Evaluation of the Uncertainty of Measurement in Calibration".

Dutch Accreditation Council RvA Page 8 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Instrument, Measure	Range	CMC ²	Remarks	Location
PV 3 1	Negative Gauge pressure	-90 kPa to -15 kPa	3.5·10 ⁻⁵ · p_e + 6.1	nitrogen, measuring and generating	LAB
		-15 kPa to 0 kPa	$3.5 \cdot 10^{-5} \cdot p_{e} + 0.48$ Pa		
TQ 0 0	Torque	0.45 to 5.6 Nm	2·10 ⁻² · <i>M</i> + 0.069 Nm	Setting Torque Tools (wrenches and drivers)	LAB
		5.6 to 41 Nm	1.5·10 ⁻² · <i>M</i> + 0.53 Nm		
		41 to 113 Nm	7·10 ⁻³ · <i>M</i> + 0.86 Nm		
		113 to 339 Nm	6-10 ⁻³ · <i>M</i> + 1.06 Nm		
TE 0 0	TEMPERATURE, HUMIDITY, THERMOPHYSICAL PROPERTIES				
TE 1 0	Resistance thermometers			also for indicators and recorder with resistance thermometers	
		5 °C to 15 °C	0.11 °C	measurements in climate chamber	LAB
		15 °C to 24 °C	0.045 °C	measurements in climate chamber	LAB
		24 °C to 65 °C	0.045 °C to 0.17 °C	measurements in climate chamber	LAB
		0.01 °C	0.0059 °C	triple point of water	LAB
		29.7646 °C	0.0068 °C	fixed point gallium	LAB
		419.527 °C	0.010 °C	fixed point zinc	LAB
		660.323 °C	0.014 °C	fixed point aluminium	LAB
		-95 °C to -80 °C	0.025 °C		LAB
		-80 °C to 125 °C	0.085 °C		LAB + OS
		-80 °C to 248 °C	0.014 °C		LAB

Dutch Accreditation Council RvA Page 9 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Instrument, Measure	Range	CMC ²	Remarks	Location
TE 1 0		248 °C to 500 °C	0.021 °C		LAB
		500 °C to 660 °C	0.053 °C		LAB
TE 3 0	Thermocouples			also for indicators and recorders with thermocouples	
		0 °C to 26 °C	0.022 °C	thermocouple Type-E	LAB
		-30 °C to 200 °C	0.16 °C		LAB + OS
		-95 °C to 660 °C	0.10 °C		LAB
		660 °C to 1000 °C	0.80 °C		LAB
		35 °C to 500 °C	0.5 °C to 1.8 °C	surface thermometers and surface calibrators	LAB
TE 4 2	Liquid-in-Glass thermometer				LAB
		-20 °C to 60 °C	0.026 °C		
		60 °C to 205 °C	0.039 °C		
TE 6 2	Radiation (infrared)			pyrometers and black body sources	LAB
		-35 °C to 550 °C	0.20 °C to 0.55 °C		
		550 °C to 1000 °C	3.5 °C		
TE 9 0	Simulators/Display units				
		-200 °C to 850 °C	0.006 °C to 0.009 °C	3) based on Pt100	LAB + OS
		0 °C to 26 °C	0.025 °C	4) thermocouple type E	LAB
		-250 °C to -200 °C	0.38 °C	4)	LAB + OS
		-200 °C to -100 °C	0.25 °C	4)	LAB + OS

Dutch Accreditation Council RvA Page 10 of 11

Normative document: EN ISO/IEC 17025:2005

Registration number: K 013

of Fluke Nederland B.V. Standaard Laboratorium

This annex is valid from: **06-06-2018** to **01-10-2019** Replaces annex dated: **09-08-2017**

HCS code	Measured quantity, Instrument, Measure	Range	CMC ²	Remarks	Location
TE 9 0		-100 °C to -25 °C	0.14 °C	4)	LAB + OS
		-25 °C to 120 °C	0.12 °C	4)	LAB + OS
		120 °C to 1000 °C	0.19 °C	4)	LAB + OS
		1000 °C to 1372 °C	0.30 °C	4)	LAB + OS
		1372 °C to 1767 °C	0.34 °C	4)	LAB + OS
TE 10 0	Calibration baths and furnaces				
		-95 °C to 660 °C	0.0003 °C	only stability uncertainty, not valid for accuracy uncertainty	LAB + OS
		-95 °C to 140 °C	0.033 °C	< -80 °C only dry well	LAB + OS
		140 °C to 660 °C	0.033 °C to 0.053 °C	liquid bath ≤ 500 °C	LAB + OS
		660 °C to 1000 °C	0.56 °C	only for furnaces	LAB
		1000 °C to 1200 °C	2.2 °C	only for furnaces	LAB
RH 0 0	Relative Humidity				LAB
		10 % rh to 70 % rh	0.37 % rh	15 °C to 50 °C	
		70 % rh to 95 % rh	0.46 % rh	15 °C to 50 °C	

Remarks:

- Calibrations inside the pressure laboratory are carried out at an ambient temperature of nominal (20 ± 2) °C, with a relative humidity of nominal (45 ± 20) %rh.
- Calibrations inside the electrical laboratory are carried out at an ambient temperature of nominal (23 ± 1) °C, with a relative humidity of nominal (45 ± 10) %rh.
- Temperature calibrations are carried out at an ambient temperature of nominal (23 ± 3) °C, with a relative humidity of nominal (45 ± 20) %rh.
- The calibrations outside the electrical laboratory are carried out at an ambient temperature of nominal (23 ± 5) °C, with a relative humidity of nominal (45 ± 20) %.
- 1) $T_e = \text{Trigger error for sine wave signals} = (4/f) \cdot 10^{-5} \cdot f$ (f = measured frequency).
- 2) Generate at $T_a = (23 \pm 3)$ °C.
- 3) Resistance Thermometers based on a Pt100. Others e.g. thermistors which actually measure resistance, see best measurement capabilities for electricity.
- 4) Thermocouple with internal reference junction compensation. Without, or with switched off reference junction compensation, which actually measures voltage, see best measurement capabilities for electricity.
- 5) T.E. = trigger error related to number of 10 MHz pulses counting during start/stop.

Dutch Accreditation Council RvA Page 11 of 11